



PATENT APPLICATION
Docket No. 5484-048
Client No. PX828-US/SSD

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Amoldt
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ORJ

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup SHIM, et al Confirmation No. 1838
Serial No. 09/305,240 Examiner: Nadav, Ori
Filed: May 4, 1999 Group Art Unit: 2811
For: OPEN DRAIN INPUT/OUTPUT STRUCTURE AND
MANUFACTURING METHOD THEREOF IN SEMICONDUCTOR
DEVICE

MAIL STOP NON FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

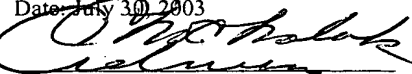
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AMENDMENT

Responsive to the Office Action dated May 13, 2003, please amend the application as follows.

Amendments to the Claims are found in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Non Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
Date: July 30, 2003

Adrienne Chocholak